STATUTORY DECLARATION

I, Takahiko NAKAZAWA, of Taiyo Seimei Otsuka Building 3F, 2-25-1, Kitaotsuka, Toshimaku, Tokyo, 170-0004, Japan, do solemnly and sincerely declare as follows:

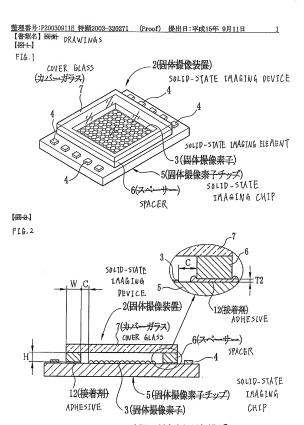
I am well acquainted with the English and Japanese languages.

The attached translation is true into the English language of the accompanying certified copy of the document filed in the name of Fuji Photo Film Co., Ltd., in the Japanese Patent Office on 11 September 2003, in respect to an application for Patent.

This 24th day of June 2009,

Jahahiko hakazawa

Takahiko NAKAZAWA



SOLID-STATE IMAGING ELEMENT

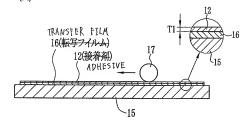
SPACER

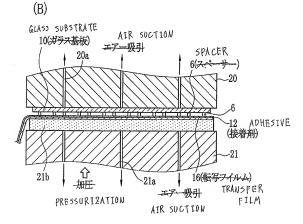
STEP 2-3 第2-3工程 AND TRANSFER FILM PEELING 5 TEP 2-4 第2-4工程 -転写フイルムの剥離

TRANSFER FILM

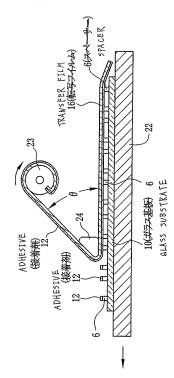
ガラス基板と転写

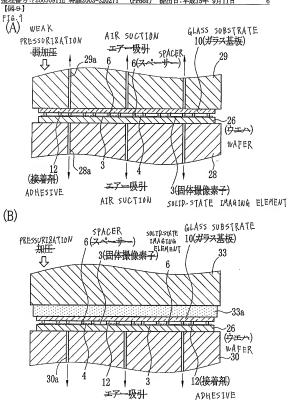
PIG. T (A)





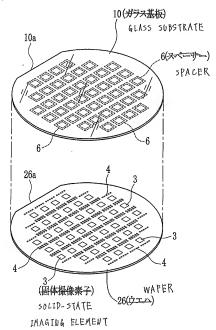
PIG.8



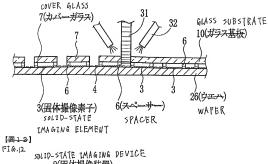


AIR SUCTION

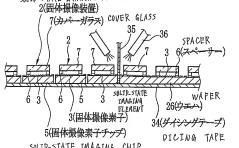
FIG. (0





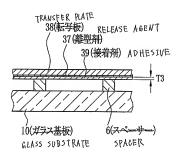


(図1-2)

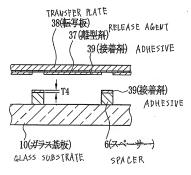


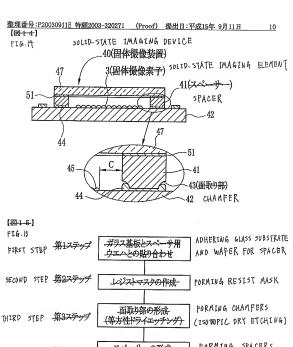
SOLID-STATE IMAGING CHIP

(図1-8) FIG.B (A)



(B)





FOURTH STEP 第4ステップ スペーサーの形成 (異方性ドライエッチング) (AMISOTROPIC DRY ETCHIMA)

FIFTH STEP 第5ステップ 接着剤の除去 AND ADHESIVE

